

- 1- What are the physical conditions governing ionization mechanism in gases dielectrics?
- 2- Based on Townsend Criteria for Breakdown in non-electronegative gaseous insulation
 - Give the meaning of <u>Spark voltage</u> and <u>Sparking distance</u>
 - Derive a relation between Spark voltage and Sparking distance
 - Explain why electronegative gases has high Breakdown value

Model Answer

- 1- What are the physical conditions governing ionization mechanism in gases dielectrics?
 - 1) Pressure
 - 2) Temperature
 - 3) Electrode configuration
 - 4) Nature of electrode surface
 - 5) Availability of initial conducting particles
- 2- Based on Townsend Criteria for Breakdown in non-electronegative gaseous insulation
 - Give the meaning of <u>Spark voltage</u> and <u>Sparking distance</u>
 - We have Town-sends criterion for BD $(\gamma e_{\alpha d} = 1)$

The voltage applied which creates the above breakdown condition is called spark

voltage Vs and the corresponding gap d is called sparking distance.

- Derive a relation between <u>Spark voltage</u> and <u>Sparking distance</u>

Town-sends current growth equation is

 $I = Io e^{\alpha d}/1 - \gamma (e^{\alpha d} - 1)$

Town-sends criterion for BD

 γ (e αd -1) = 1

Since e $\alpha d >>>1$

The criterion becomes

 $\gamma e^{\alpha d} = 1$

Where γ = Town-sends secondary ionization coefficient

 α = Town-sends primary ionization coefficient

d = gap

Sparking distance d =[Ln (1/ γ)]/ α

Spark voltage V=E d

- Explain why electronegative gases has high Breakdown value

- The molecules of (SF6 gas) electronegative gases have the property of electron attachment, (i.e., the outermost orbit of the molecules has holes)
- There molecules attach the electrons in the gap to become negative ions
- Negative ions have lesser mobility than electron
- This attachment plays an effective role of removing electrons which otherwise have led to current growth and break down
- Number of attaching electrons made by one electron drifting 1 cm in the direction of the field is called attachment coefficient.